

In re Application of)
 Tadahiro OHMI et al.)
 Serial No. 09/581,878) Group:
 Filed: June 19, 2000)
 Title: SEMICONDUCTOR MANUFACTURING) Examiner:
 APPARATUS)

526 Rec'd PCT/PTO 03 JUL 2000

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CA

10/31/00

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents and Trademarks
 Box: Patent Application
 Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. § 1.56, Applicant wishes to bring to the attention of the Examiner the documents identified on the attached form PTO-1449. Applicant respectfully requests that these documents be made of record in the present application.

A copy of each of the documents is enclosed.

A concise statement of any non-English document having an English abstract is contained in such abstract, which is incorporated herein by reference.

It is respectfully requested that the Examiner indicate consideration of the cited references by returning a copy of the attached form PTO-1449 with initials or other appropriate marks.

Respectfully submitted,


 Randall J. Knuth
 Registration No. 34,644

RJK/jrc

CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO: COMMISSIONER OF PATENTS AND TRADEMARKS, WASHINGTON, DC 20231, ON: June 29, 2000

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SIGNATURE

June 29, 2000

DATE

Enc. Form PTO-1449
 Cited Art References
 Return postcard